# TEL Tokyo Electron Alpha 8S-Z
# Detail Configuration

| | General Configuration | Available | None | |
|---|---|---|---|---|
| 1 | Process | Oxide | | |
| 2 | Wafer Size | 200mm | | |
| 3 | Process Wafer Qty | XXX | | |
| 4 | Process Type | Oxide | | |
| 5 | I/O Port / Smif | I/O port | | |
| 6 | Load Lock | NO | | |
| 7 | Carriet Slor | 25 Slot | | |
| 8 | boat type | Two boat | | |
| | System Control | Available | None | |
| 1 | System Controller | Waves | | |
| 2 | Operation Screen | Touch Screen | | |
| 3 | Gas Flow Chart (Fornt & Rear) | ◎ | ◎ | |
| 4 | Temperature Controller | M560 | | |
| 5 | Vacuum Pressure Control | N/A | | |
| 6 | Controller Transformer | 1Φ 100V | | |
| 7 | Heater Transformer | 3Φ 440V | | |
| 8 | Oxygen Analyzer | N/A | | |
| 9 | HEC Pyro Ctl | YES | | |
| 10 | RCU BOX | YES | | |
| 11 | Power BOX | YES | | |